



862.C2072

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deurs
PATENT APPLICATION *5.23.01*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASATO MURAKI ET AL.)
Application No.: 09/733,980)
Filed: December 12, 2000)
For: CHARGED-PARTICLE BEAM)
EXPOSURE APPARATUS,)
CHARGED-PARTICLE BEAM)
EXPOSURE METHOD, CONTROL :
DATA DETERMINATION)
METHOD, AND DEVICE :
MANUFACTURING METHOD)
USING THIS METHOD : May 16, 2001

RECEIVED
MAY 21 2001
TC 2800 MAIL ROOM

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form PTO-
1449. Copies of the listed documents are also enclosed.



The Examiner's attention is also directed to the following U.S. applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/537,686	3/29/00	2879
09/069,748	4/30/98	2878
09/639,078	8/16/00	2878
09/733,973	12/12/00	2879

A copy of each cited Application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All



Correspondence should continue to be directed to our address
given below.

Respectfully submitted,

Ed P. Diama

Attorney for Applicants

Registration No. 29, 296

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